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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Masataka HASEGAWA, et al.

SERIAL NUMBER: 10/090,771 GROUP: 1762

FILED: March 6, 2002 EXAMINER: CHEN, BRET P.

FOR: METHOD FOR THE FABRICATION OF A DIAMOND SEMICONDUCTOR

**REQUEST FOR PRIORITY ACKNOWLEDGMENT UNDER 35 U.S.C. 119
AND THE INTERNATIONAL CONVENTION**

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SIR:

In the matter of the above-identified application for patent, notice is hereby given that the Applicant(s) claim as priority:

<u>Country</u>	<u>Application No.</u>	<u>Month/Day/Year</u>
JAPAN	11-206858	July 21, 1999

A Certified copy of the corresponding Convention Application was filed in Serial Number 09/621,360, filed July 21, 2000, of which this application is a Divisional.

Respectfully submitted,

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